



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/512,968  
Filing Date ..... February 24, 2000  
Inventor ..... David R. Hembree  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2832  
Examiner ..... V. Nguyen  
Attorney's Docket No. .... MI22-1363  
Title: "Wafer Processing Apparatuses and Electronic Device Workpiece Processing  
Apparatuses (As Amended)"

#1510  
filed  
10-10-01

PRELIMINARY AMENDMENT

To: Box RCE  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)  
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Sir:

Responsive to the Office Action dated June 26, 2001, Applicant amends and  
remarks as follows:

AMENDMENTS

In the Specification

At page 1 before the "Technical Field" section please insert:

--RELATED PATENT DATA

7  
This patent resulted from a divisional of and claims priority to U.S. Patent  
Application Serial No 09/137,629, filed on August 21, 1998, now U.S. Patent No.